

PREFACE

This volume contains 84 contributions to the 4th International Autumn Meeting "Gettering and Defect Engineering in Semiconductor Technology" - GADEST '91. For some missing papers the abstracts were printed.

The manuscripts are from 60 research institutes of 18 countries and will give a representative survey of the present state of knowledge.

Since the days of GADEST '89 up to now a complicated process of change in the eastern part of Germany takes place. Due to the active support of numerous "friends of GADEST", especially the members of our Scientific Program Committee, the Autumn Meeting becomes possible in October 1991 despite of the complicated situation of change. The Meeting could not take place without the financial support provided by

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The large interest emphasises again the fundamental idea of the Meeting serving as a forum of scientists and engineers from East and West, both, for providing deeper insight into defects in semiconductors and for discussing important effects of gettingter and defect engineering.

The dedicated work of the Organizing Committee is gratefully acknowledged.

Finally, the 5th International Autumn Meeting will be held 1993.

Frankfurt (Oder)
July, 1991

Martin Kittler, Chairman GADEST '91

Hans Richter, Co-Chairman GADEST '91

